# Chemically etched fiber-optic coupler with tunable splitting ratio

Sudip K. Chatterjee<sup>1</sup>, Saba N. Khan<sup>2</sup>, Abhinav Kumar<sup>3</sup>, Partha Roy Chaudhuri<sup>3</sup>

<sup>1</sup> The Centre for Lasers & Photonics, Indian Institute of Technology Kanpur, Uttar Pradesh-208016, India

<sup>2</sup> Department of Physics, Indian Institute of Technology Delhi, New Delhi-110016, India

<sup>3</sup> Department of Physics, Indian Institute of Technology Kharagpur, West Bengal-721302, India

E-mail: <a href="mailto:skc.iitkgp.work@gmail.com">skc.iitkgp.work@gmail.com</a>

## 1. Introduction

Fused coupler, an all-fiber passive branching component plays a key role in fiber optic communication network for light branching/splitting, wavelength multiplexing/ de-multiplexing, filtering, polarization selective splitting etc. [1,2]. The fabrication of fused-coupler has been achieved using several methods namely, Flame fusion, Optical irradiation etc. [3] and the technology is fully developed. However, an already fabricated fused coupler having a fixed power-splitting ratio at a particular wavelength cannot be achieved for any other wavelength unless the coupling segment gets reformed. In this research, we developed a dynamic light-coupling circuit by chemically etching a pair of twisted, identical SMF-28 fibers and tuning their coupling ratio by dipping the segment into a liquid with variable refractive indices (RI). The performance of such devices in terms of twisted length, number of turns and the excitation wavelength has also been investigated.

### 2. Experimental setup

Initially, the active segment of the coupler is formed by twisting two identical and cleaved SMF-28 fibers and fixing it on two micro-positioner stages. The composite optical circuit is then made in contact with a potential etchant (40% conc. Hydrofluoric acid, HF), placed on a 3-D translational stage (MTS series, Holmarc), to reduce the overall dimension of the constituting fibers such that evanescent wave interaction can take place. The input port of this  $2\times 2$  system is then connected to the 1310 nm source and the output ports (transmitted port and coupled port) to the detectors (S-142C, Thorlabs) to monitor/control the coupling such that the preservation of the coupler having a desired splitting ratio can be attained. As soon as the etchant is removed, the segment is then dipped in the NaOH



Laser Source @ 1310 nm Positioner Stage

Fig. 1: Experimental setup

solution to detach the remaining HF solution followed by washed in de-ionized water, till the moment output power stabilize, to make device contamination-free. The test segment is then fixed on a  $\pi$ -shaped frame which is further immersed in the glycerin solution of varying concentration from 10% to 80% (equivalent to RI change from 1.344 to 1.443). The output power from both the detector is measured through power meter (PM320E, Thorlabs).

#### 3. Results and discussion

Out of a series of experiment that has been carried out, in Fig. 2, the direct-port and coupled-port power of a typical test coupler (characterized by cleaved length  $\sim 8$ cm, twisted length  $\sim$  4cm, number of twist = 4) is plotted at the operating wavelength 1310 nm. An increase in the coupling efficiency from 18.5 dB to 2.4 dB is achieved with the increase in glycerin concentration ( $\lambda$ =1.31 µm). However, the efficiency can be enhanced further from 10.7 dB to 0.11 dB at  $\lambda$ =1.55 µm. The spectral characteristic of such coupler has also been studied by illuminating the input port with the broadband source and measuring the output spectra through optical spectrum analyzer (Agilent 86146B). A complimentary output at the coupled port with respect to the transmitted port is observed for a wavelength band from 1200 nm to 1600 nm. The qualitative demonstration through a theoretical model is underway and would be presented in detail in the conference.



Fig. 2: The variation of direct port and coupled port power as a function of glycerin concentration at 1310 nm

#### References

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